

Notice of References Cited	Application/Control No. 10/774,960	Applicant(s)/Patent Under Reexamination NAKANISHI ET AL.	
	Examiner Mark Consilvio	Art Unit 2872	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,363,226	11-1994	Strasser et al.	359/566
	B	US-5,910,940	06-1999	Guerra, John M.	369/275.1
	C	US-5,726,805	03-1998	Kaushik et al.	359/589
	D	US-5,561,558	10-1996	Shiono et al.	359/569
	E	US-2005/0002313	01-2005	Hayashi, Kenichi	369/112.03
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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